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P.01/04

OCT 21 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application Serial No. 10/607,869
Filing Date June 27, 2003
Inventor Zhongze Wang
Assignee Micron Technology, Inc.
Group Art Unit 2812
Examiner Jennifer M. Kennedy
Attorney Docket No. MI22-2343
Customer No. 021567
Title: Method of Forming Silicon-on-Insulator Comprising Integrated Circuitry

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

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2. Transmittal Form
3. Statement of the Substance of the Interview

Dated:

10/21/04

By:

Pat Palmer

Pat Palmer
Telephone No. (509) 624-4276
Facsimile No. (509) 838-3424

NUMBER OF PAGES IN FACSIMILE: 4

PTO/SB/21 (09-04)

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FORM**

(to be used for all correspondence after initial filing)

Total Number of Pages in This Submission

Application Number	10/607,869
Filing Date	June 27, 2003
First Named Inventor	Zhongze Wang
Art Unit	2812
Examiner Name	Jennifer M. Kennedy
Attorney Docket Number	MI22-2343

Total Number of Pages in This Submission

ENCLOSURES (Check all that apply)

- Fee Transmittal Form
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- Amendment/Reply
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- Drawing(s)
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 Petition to Convert to a Provisional Application
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Statement of the Substance of the Interview
(of 10/18/04)**SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT**Firm Name
Wells St. John P.S.

Signature

Printed name
Mark S. Matkin

Date

10/21/04

Reg. No.

32,268

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Assignee Micron Technology, Inc.
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Examiner Jennifer M. Kennedy
Attorney's Docket No. MI22-2343
Customer No. 021567
Title: Method of Forming Silicon-on-Insulator Comprising Integrated Circuitry

STATEMENT OF THE SUBSTANCE OF THE INTERVIEW

To: Commissioner for Patents
ATTENTION: Examiner Jennifer M. Kennedy
Group Art Unit 2812
P. O. Box 1450
Alexandria, VA 22313-1450 **VIA FACSIMILE**

From: Mark Matkin (Tel. 509-624-4276; Fax 509-838-3424)
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601 West First Avenue, Suite 1300
Spokane, WA 99201-3828

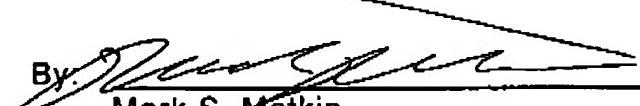
An interview was conducted between the undersigned and Examiner Kennedy on October 18, 2004.

The undersigned emphasized those amendments and arguments pertaining thereto in the Response filed on September 23, 2004. Specifically with respect to claim 49, it was asserted that the added limitation of the insulator layer being formed at least by forming a first silicon dioxide layer on a first substrate, forming a second silicon dioxide layer on a second substrate and joining the first substrate to the second substrate was not taught or suggested by the applied art in combination with

the other claim 49 limitations. The Examiner agreed generally that such amendments defined patentable subject matter, subject to further searching and consideration. The undersigned also asserted that the withdrawn claims should now come back into this application, and be allowed.

Respectfully submitted,

Dated: 10-21-04

By 
Mark S. Matkin
Reg. No. 32,268